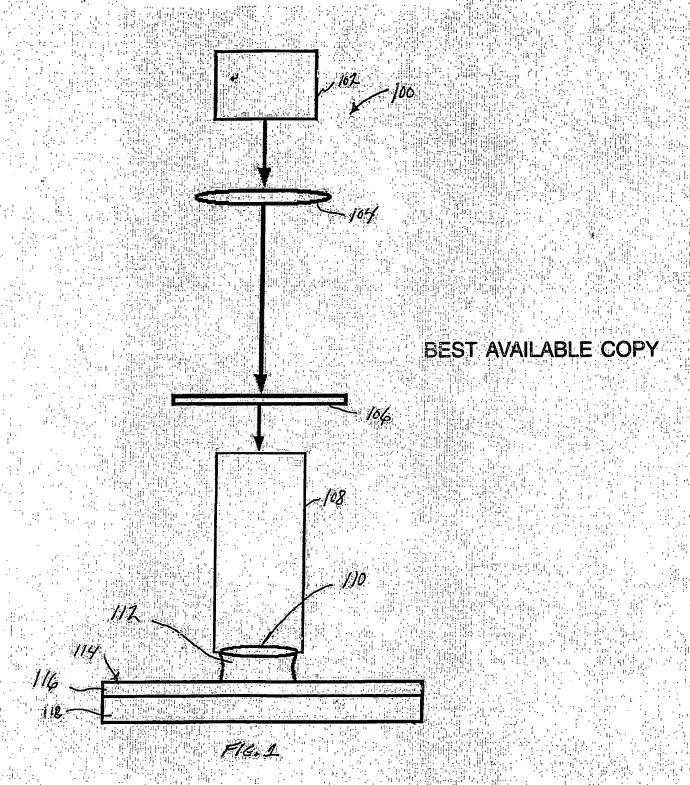
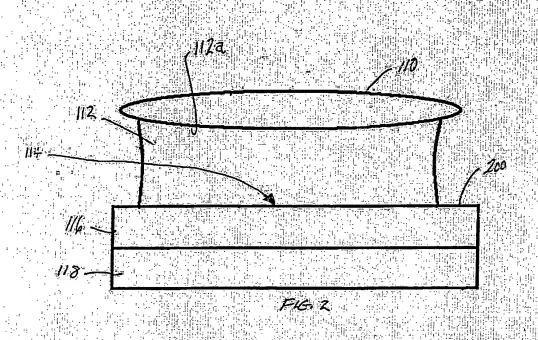
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5、海里是中国国际通过设置的 10、各位的国际中国



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